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APPLICANTS

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** CONTINUING DATA *****
 This application is a CON of 09/423,969 11/17/1999 ABN
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** FOREIGN APPLICATIONS *****
 JAPAN 10-67508 03/17/1998
 JAPAN 11-32123 02/10/1999
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35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	EXAMINER'S SIGNATURE <i>Sum</i>	INITIALS <i>sm</i>		

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 25944
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TITLE
 Method of forming thin film patterning substrate including formation of banks

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
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